

Abstract

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Chip Scale Marker And Marking Method

5 A chip scale marker includes a laser system performing laser marking, a
wafer holder on which a wafer subject to the laser marking is mounted, the wafer
holder comprising a vacuum plate disposed at a center of the wafer holder for
sucking the wafer and a wafer rotating unit provided at a circumference of the
vacuum plate and having an open area facing the laser system, a camera disposed
10 above the wafer holder to photograph the wafer, and a warpage removing unit
provided above the wafer holder for removing warpage from the wafer.

Figure 4



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